

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshihiro ITO et al.	Art Unit: 2893
Application No.: 10/518,945	
Confirmation No.: 4943	Examiner: T. Nguyen
Filing or 371(c) Date: March 16, 2006	
Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	

**AMENDMENT UNDER 37 C.F.R. § 1.312**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR § 1.312, please amend the above-captioned application as follows:

- ☒ **Amendments to the Specification** begin on page 2 of this paper.
- ☐ **Amendments to the Claims** are reflected in the listing of the claims which begins on page      of this paper.
- ☐ **Amendments to the Drawings** begin on page      of this paper and include an attached replacement sheet. An **Appendix** including the amended drawing figures is attached following page      of this paper.
- ☒ **Remarks/Arguments** begin on page 3 of this paper.

Please note, if a box is not checked, then no corresponding amendment is being made.